

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Robert P. Freese et al.

Confirmation No.: 8346

Application No.: 10/661,917

Group Art Unit: 1756

Filed: September 11, 2003

Examiner: Daborah Chacko Davis

For: METHODS FOR MASTERING MICROSTRUCTURES THROUGH A  
SUBSTRATE USING NEGATIVE PHOTORESIST

August 17, 2006

Mail Stop Amendment  
Commissioner for Patents  
Box 1450  
Alexandria, VA 22313-1450

**SUPPLEMENTAL AMENDMENT**

Sir:

Please enter the following Supplemental Amendment before substantive examination of the present application.

It is not believed that an extension of time and/or additional fee(s)-including fees for net addition of claims-are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.

**Amendments** to the claims begin on Page 3 of this paper.

**Remarks** begin on Page 9 of this paper.